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PATENT  
Attorney Docket No.: SAM-0477  
Customer No.: 29344

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Young-kuk Jeong, *et al.*

Examiner: Blum, David S.

Serial No.: 10/696,465

Group Art Unit: 2813

Filing Date: October 29, 2003

Title: METHOD OF MANUFACTURING CAPACITOR OF SEMICONDUCTOR  
DEVICE BY SIMPLIFYING PROCESS OF FORMING DIELECTRIC LAYER  
AND APPARATUS THEREFOR

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

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02/17/06

Date

Christina Harris

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
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TRANSMITTAL LETTER

Sir:

Enclosed herewith for filing in the above-identified patent application please find the following listed items:

1. Amendment Transmittal;
2. Amendment After Final Rejection in response to Office Action mailed on December 20, 2005; and
3. Return Postcard

In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. A duplicate copy of this letter is provided for this purpose.

Respectfully submitted,

Date: February 17, 2006  
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